Application/Control No.	Applicant(s)/Patent under Reexamination		
10/626,096	LEE ET AL.		
Examiner	Art Unit		
DAMDMI	2818		

SEARCHED						
Class	Subclass	Date	Examiner			
438	201, 211; 257, 260; 264, 482	2/16/2005	DV			
	486	2/16/2005	DV			
257	314-316	2/16/2005	DV			
	239	2/16/2005	DV			

INI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
		DATE	EXMR		
EAST		2/16/2005	DV		
EAST		2/16/2005	DV		
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